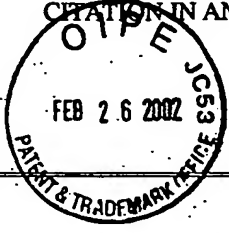
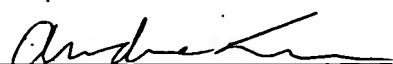


FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <div style="text-align: center;">  </div>				DOCKET NUMBER SLA 1028		SERIAL NUMBER 10/003,800	
				APPLICANT Andrew R. Ferlitsch			
				<div style="border: 1px solid black; padding: 5px; display: inline-block;"> RECEIVED MAR 05 2002 2624 AL Technology Center 2600 </div>			
FILING DATE: 10/23/2001				GROUP ART UNIT 2624 AL			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FIL. DATE IF APPROP.	
AL	5982996	11/9/1999	Snyders	395	114	3/13/1997	
AL	5528734	6/18/1996	Sanchez	395	115	5/31/1994	
AL	5287194	2/15/1994	Lobiondo	358	296	11/25/1992	
AL	5845058	12/1/1998	Shaw et al.	395	114	11/20/1996	
AL	6,248,996	06/19/2001	Johnson et al.	250	234	07/12/1999	
AL	6,229,622	05/08/2001	Takeda	358	1.16	02/28/1997	
AL	2001/0038462 A1	11/8/2001	Teeuwen et al.	358	1.15	12/05/2000	
AL	6,337,745	01/08/2002	Aiello, Jr. et al.	358	1.15	09/05/1997	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY/NAME	CLASS	SUB CLAS S	TRANSLATIO N YES NO	
AL	04-199218	07/20/1992	Japan			Abstract	
AL	10-031750	02/03/1998	Japan			Abstract	
AL	10-207643	08/07/1998	Japan			Abstract	
AL	11-024860	01/29/1999	Japan			Abstract	
AL	2000-151873	05/30/2000	Japan			Abstract	
AL	64-014043	01/18/1989	Japan			Abstract	
AL	2000-099303	04/07/2000	Japan			Abstract	
AL	05-270064	10/19/1993	Japan			Abstract	
AL	06-004239	01/14/1994	Japan			Abstract	
AL	11-015608	01/22/1999	Japan			Abstract	
AL	10-340167	12/22/1998	Japan			Abstract	
AL	11-143661	05/28/1999	Japan			Abstract	
AL	10-340166	12/22/1998	Japan			Abstract	
AL	2000-132347	05/12/2000	Japan			Abstract	
AL	09-030040	02/04/1997	Japan			Abstract	
AL	10-027149	01/27/1998	Japan			Abstract	
AL	10-187393	07/14/1998	Japan			Abstract	
AL	2001-088405	04/03/2001	Japan			Abstract	
AL	08-101754	04/16/1996	Japan			Abstract	
AL	09-319530	12/12/1997	Japan			Abstract	
AL	10-283130	10/23/1998	Japan			Abstract	
EXAMINER			DATE CONSIDERED				
			6/2/05				